

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	LOW TEMPERATURE POLYSILICON THIN FILM TRANSISTOR AND METHOD OF FABRICATING LIGHTLY DOPED DRAIN THEREOF	
Application Number :		
Date :		
First Named Applicant:	Mr. Hsi-Ming Chang	
Confirmation Number:		
Attorney Docket Number:	13530-US-PA	
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>		
Submitted By:		Elec. Sign.
Dr. Belinda Lee Registered Number: 46,863		/Belinda Lee/ Sign. Capacity Agent

Documents being submitted:	Files
us-assignment	13530-usassn.xml us-assignment.xsl us-assignment.dtd 13530assignment01.tif 13530assignment02.tif
us-request	13530-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	13530-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-declaration	13530declaration01.tif
us-declaration	13530declaration02.tif
application-body	13530usf.xml application-body.dtd Image1.tif Image2.tif Image3.tif Image4.tif Image5.tif Image6.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xsl

application-body-pdf-wrap	wipo.ent
abstract-pdf	13530usf-pdf-wrap.xml
claims-pdf	13530usf-abst.pdf
description-pdf	13530usf-clms.pdf
drawings-pdf	13530usf-desc.pdf
Comments	
Please be kindly advised that the indicated fee of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fee in connection with this application to Deposit Account No. 50-2620(Order No. 13530-US-PA). Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: Belinda@jcipgroup.com.tw; usa@jcipgroup.com.tw	